



EV549570925

Inventory: **Yongjun Jeff Hu**

Title: **Methods of Forming Metal Silicide**

Assignee: **Micron Technology, Inc.**

Serial No.: **10/609,282**

Filed: **June 26, 2003 [RCE Filed Herewith]**

INFORMATION DISCLOSURE STATEMENT

PURSUANT TO 37 C.F.R. §§ 1.56, 1.97 AND 1.98

The attached Form PTO-1449 is submitted in compliance with 37 CFR §1.56. Pursuant to FEDERAL REGISTER, Vol. 69, No. 182, pg. 56542 (September 21, 2004), no copies of any cited U.S. patents or U.S. published applications are included herewith. No admission is made regarding whether the listed references are prior art.

Citation of these references is respectfully requested.

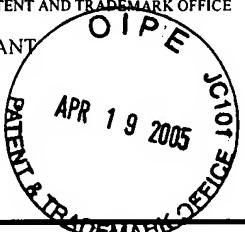
Date: 4/19/05

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Respectfully submitted,

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Form PTO-1449		U.S. DEPARTMENT OF COMMERCE PATENT AND TRADEMARK OFFICE		ATTY. DOCKET NO. MI22-2266	SERIAL NO. 10/609,282		
LIST OF ART CITED BY APPLICANT (Use several sheets if necessary)							
				APPLICANT Yongjun J. Hu			
				FILING DATE June 26, 2003 [RCE filed herewith]	GROUP 2812		
U.S. PATENT DOCUMENTS							
*Examiner Initial		Document Number	Date	Name	Class	Subclass	Filing Date If Appropriate
	AA	4,886,764	12/89	Miller et al.			
	AB	5,973,351	10/99	Kotecki et al.			
	AC						
	AD						
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	AH						
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FOREIGN PATENT DOCUMENTS						Translation <input checked="" type="checkbox"/> Yes <input type="checkbox"/> No	
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